Thermal Interface Materials:

I. Categorization, Developments, and SelectionII. Testing Methodologies and Test Systems

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Agenda:

- I. Categorization, Selection, and New Developments for TIMs
 - A. Categorization methodology for thermal interface materials (TIMs)
 - B. Identification of TIM designations
 - C. Recent developments of new materials in new TIM categories
- II. TIM Industry Testing Methodologies and Test Systems

Addendum

Note: This presentation is focused primarily for materials useful for components and mil/aerospace systems. In addition, many TIM types described may be selected to meet other applications.



A. Categorization, Selection, and Developments for Thermal Interface Materials

Importance of Thermal Resistance: Power Semiconductors



Empirical Analysis, TO-220 Package Materials Thermal Resistance Contribution

| | - | | |
|-----------------------|----------|-------------|-------------------------|
| Material Layer | BLT (μm) | λ (W/mK) | Percent of Total (%) |
| Die (Si) | 100 | 150 | 6 |
| Die Attach (Solder) | 20 | 50 | 3 |
| Substrate (Cu) | 200 | 380 | 2 |
| TIM2 (Thermal Grease) | 100 | 5 | 71 |
| Heat Sink (Al) | 2000 | 180 | 10 |
| Other | - | - | 8 |
| Total | - | - | 100 |

Data Source: Berliner Nanotest und Design GmbH (Germany). Used with permission.

Overview: Thermal Interface Material Function



System thermal management is the sum of a series of thermal resistances:



Heat sink: Inherent bulk material property – typically aluminum or copper (heat sink, liquid cold plate, vapor chamber)

TIM2: *External* to semiconductor package; θ_{T2} is determined by material resistance, which consists of bulk value plus (2) contact resistances (case surface, heat sink)

Case (or lid): Inherent bulk material property – typically nickel-plated copper*

TIM1: *Internal* to semiconductor package; θ_{T1-C} is determined by the material resistance which consists of bulk value plus (2)contact resistances (die surface, lid interior surface); or, **TIM0**: Semiconductor package without lid ("bare die" package)

Die: Inherent bulk material property (Si, SiC, GaN, GaAs, other)

Note: Aluminum for low-power IC packages; aluminum or nickel-plated copper for "paddle" for TO-style power semiconductors and "top-side cooled" power semiconductor modules.

Overview: Thermal Interface Material Function



The primary performance value for a thermal interface material is thermal resistance per unit area (previously referred to as thermal impedance):

°C-in²/W or °C-cm²/W (also commonly used, °C-mm²/W)

- Vendor data sheet performance values are typically expressed as thermal resistance versus clamping force applied (range, typically 0-100PSI).
- In a performance graph, thermal resistance appears on the Y-axis versus clamping force on the X-axis.
- Increased clamping force has a large impact on thinning a TIM and improving (*lowering*) the thermal resistance value.
 - Values are typically asymptotic.
 - General function of a TIM is heat transfer across an interface.

Overview: TIMs for Specific Semiconductor Segments



Many different semiconductor package and module types are utilized across industry, with widely-varying TIM application requirements:

- Semiconductor segment, type, and package or module type will impact specific performance requirements, applicable TIM types, performance;
- Individual market segments have widely varying:
 - Package construction, type of heat source, relative heat flux
 - Current major market needs: (A) Very high performance *thin* TIMs
 (B) Thick high conductivity *gap-filling* TIMs

Example: Military X-band radar modules -- extremely high cost and test is critical at different stages of module assembly -- with reworkability a critical requirement, which drives TIM selection criteria.

• Major components requiring TIMs: diode lasers, power, RF, ICs, EV batteries, photonics



TIM Terminology

Proper use of terminology is important:

• All applications *external to the semiconductor package* are TIM2:



Note: The earlier term adopted as "TIM 1.5" was replaced with "TIM 0" twenty years ago. The three standard terms are TIM0, TIM1, TIM2. Source: Boteler, L., "Thermal Design of Power Electronics," US Army RDECOM Army Research Laboratory, APEC 2019 Conference, Tutorial (March 2019).

TIM Terminology



| Thermal Interface Material Application Terminology | | | | |
|--|---|-----------------|--|--|
| Package Level | Generally Accepted Definition | TIM Terminology | | |
| 1 | Semiconductor die to heat sink (external, bare die package) | TIM0 | | |
| 1 | Semiconductor die to package lid (internal, lidded package) | TIM1 | | |
| 2 | Semiconductor lid, case, or baseplate: external to the package, conducting heat to a heat sink, liquid cold plate, or metal component | TIM2 | | |
| 3 | Conducting heat from one or more components across a relatively large gap to a metal component. Material thickness \geq 250µm (0.10" (typ.) | Gap-filler | | |
| 4 | Platform or subassembly level, conducting heat from the case of a power supply or other large module, large heat sink, metal component | Gap-filler | | |



TIM Terminology

Proper use of terminology is important:

- Intel/AMD use of *reflowed indium solders* for TIM1 (within the semiconductor package) is a separate category of TIM application.
 - The term "Solder TIM (STIM)" is appropriate only to these packages.
 - The term "STIM" is *not appropriate* for use in other TIM applications and only creates confusion.
 - A Solder TIM has different formulation and requirements than a liquid metal TIM.
- Die attach materials are not categorized as TIMs.
- Solders are otherwise not categorized as TIMs.

Note: All solders and die attach materials generally have thermal characteristics and provide a heat flow path -- but are not considered in the general terminology usage as thermal interface materials (TIMs). Solders and die attach materials are selected by different criteria as the primary function is <u>electrical interconnect</u>. In very limited cases, a die attach gel has been used as a TIM1.

TIM and Thermal Performance Terminology



| Thermal Interface Material Performance Terminology | | | | |
|--|--|---|--|--|
| Term | Generally Accepted Definition | Value (Typ.) | | |
| Thermal Resistance (Bulk) | Barrier to flow of heat from heat source through a material or component | °C/W | | |
| Thermal Resistance (Interfacial) | Barrier to the flow of heat at the surface of a component | °C/W | | |
| Thermal Resistance (Contact) | Alternative term for interfacial thermal resistance (per above) | °C/W | | |
| Thermal Resistance (per unit area)* | Barrier to the flow of heat through a material, per unit area (most useful value for selecting a TIM) | °C-in²/W (or) °C-cm²/W | | |
| Thermal Impedance | Alternative term for thermal resistance per unit area | °C-in²/W (or) °C-cm²/W | | |
| Heat Flux (Heat Density)* | Amount of power dissipated per unit area (e.g., from a point on the surface of a processor die or across the baseplate of a GaN RF device) | W/in ² (or) W/cm ² | | |

Note: The above terminology may be used casually and identifying the most useful term is important for selecting a TIM to propose for a given application. The most important term for determining performance of a TIM is thermal resistance per unit area, marked above with an asterisk (*).

TIM Categorization System



| General Functions and Categories of Thermal Interface Materials | aterials | |
|---|----------|--|
|---|----------|--|

| Primary Function | Material Category | Sub-Categories | | |
|-------------------------------------|--|--|---|--|
| Largo (>250um) air gans | Gap-fillers ¹ | | Die-cut sheet or preform | |
| Large (<u>></u> 250µm) an gaps | | | Dispensable liquid | |
| Electrically non-conductive | Dielectric ¹ | | | |
| Large area: X-Y-direction heat flow | Graphite Sheets ² | • | Many different, generally poor Z | |
| Large area: Z-direction heat flow | Elastomeric Sheets ¹ | | Many different, generally poor conductivity | |
| Adhaciwa TINA attachmant | Thermally-conductive adhesives*1 | | Pressure-sensitive adhesives (PSAs) | |
| | | | Curable or two-part dispensed | |
| | TIM1 ^{#1, 3} | | Die-attach (DA) Adhesives (used as TIM1) | |
| | | | Gels | |
| Die-to-lid (internal to package) | | | Phase-change, Thermal greases | |
| | | | Reflowed soft solders (indium), liquid metals (gallium) | |
| | | • | VA-CNT (carbon nanotubes), VA-CNF carbon (fibers) | |
| This multipurpose $(TINIO/1 # /2)$ | Thermal greases (compounds) ¹ | Many thermal filler percentages (user beware | | |
| | Phase-change compounds ¹ | Many different PC temperatures, formulations | | |

Notes: * Pressure-sensitive adhesives (PSAs) preforms may be manufactured with a carrier, with adhesive coating on two surfaces. # TIM1 selection is determined by the semiconductor device manufacturer. Key: 1. Polymeric. 2. Graphitic. 3. Metallic.

TIM Categorization System



| General Functions and Categories of Thermal Interface Materials | | | | | | |
|---|---|---|--|--|--|--|
| Primary Function | Material Category | Sub-Categories | | | | |
| | Graphene-enhanced graphite ² | Graphene-enhanced graphitic preforms | | | | |
| | Carbon-Based Arrays ² | VA-CNF: Vertically-aligned carbon fiber arrays VA-CNT: Vertically-aligned carbon nanotube arrays | | | | |
| Very high performance | Metallic ³ | TIM0/1[#] Liquid metal (LM) TIM0/1[#] Liquid metal/solid hybrids (LMH) TIM1[#] Reflowed soft solders (STIM, indium) TIM0/1[#]/2 Phase-change metal alloys (PCMA) TIM2 Metallic preforms (flat foils, patterned foils) | | | | |

Notes: * Pressure-sensitive adhesives (PSAs) preforms may be manufactured with a carrier, with adhesive coating on two surfaces. # TIM1 selection is determined by the semiconductor device manufacturer.

TIM Categorization System



| Thermal Interface Material Categorization and Evaluation | | | | | | |
|--|--|---|---------|--|----------------------------|--|
| Prioritized TIM Requirements | Property | Typical Value | | Alternative/Opp | Alternative/Opposing Value | |
| 1. Electrical | Dielectric Properties | Electrically Non-Conductive | | | | |
| | Fastening | Mechanical Fasteners Required | | Adhesive | | |
| 2. Mechanical | Thickness | Minimum: Highest Performance | | Maximum (<u>></u> 250µm): Gap-filling | | |
| | Surface Roughness, Flatness, Warpage | Minimum Specification | | Maximum Specification | | |
| 3. Application Process | Dispensing/Placement | Automated, Semi-auto | | Manual | | |
| | Thermal Resistance | Minimum | Maximum | Minimum | Maximum | |
| 4. Thermal | Operating Temperature Range | Minimum | Maximum | Minimum | Maximum | |
| | UL Flammability Rating | UL V-0 | | (Not specified) | | |
| 5. Cost | Material only/application process/total cost | Material (only) | | Application process cost, shipping requirement cost | | |
| 6. Health and Safety, Climate and Environmental | Constituent analysis: silicones, toxicity, environmental, H&HS | Government, industry, company regulations | | ations | | |

TIM Performance



Determining performance for selecting an appropriate TIM:

- Clamping force uniformly applied is intended to achieve:
 - Maximized surface wetting;
 - Thinnest possible TIM thickness (to minimize bulk thermal conductivity);
- Degree of surface wetting achieved is critical to overall performance, to minimize contact thermal resistance at each of two contact surfaces.
 - Contact resistance dominates TIM bulk resistance for most materials.
 - Achieving the thinnest possible thickness with highest clamping pressure is critical to achieving minimum thermal resistance.
- Relatively good bulk thermal conductivity is needed when only limited clamping force and sufficient surface wettig are available.

TIM Selection Methodology



Thermal performance is not the only criteria for selection of a TIM.

- A *holistic application view* may require a specific temperature range, application process, or reliability requirement that determines material selection, over thermal performance;
- As a result, the single *lowest thermal resistance* material or the material having the *highest bulk thermal conductivity* may not be selected.
- A material must meet thermal resistance *and* all other requirements: material compatibility, wetting, compression, rheology, assembly procedures, reliability, product life.

TIM Selection Methodology





TIM Selection Methodology



Selecting an appropriate thermal interface material:

- Degree of surface wetting achieved is critical to overall performance, to minimize contact thermal resistance at each of two contact surfaces.
 - Contact thermal resistances dominate TIM total thermal resistance value for most materials that are thin by design;
 - Exception: Gap-filler bulk thermal resistance will dominate over contact thermal resistance, due to intentional extreme thickness.
 - Certain of these factors (such as filler percentage by volume) can impact the ability of a TIM to move and not suffer "run-out" (highly thixotropic), affecting relative *thermal performance* and *reliability over time*.
 - Driving to *highest wetting* and *thinnest clamped* thickness is *critical to successful TIM selection* in traditional TIM applications.



Major TIM Categories

Presentation Note: Slides in this section are included for future review by those interested, but the majority will not be covered in today's oral presentation.

Gap-Fillers: Where Are These Needed?

One general definition for TIMs versus gap-fillers:

- Thermal Interface Materials: Replace air in an interface that would otherwise present due to <u>surface roughness;</u>
 - Thinnest TIM is typically best performer
- Thermal Gap-fillers: Replace air in an interface that would otherwise be present due to tolerance stack-up.
 - Typically defined as <a>>250µm thickness

Note that these are very generalized definitions.



Thermal Interface Material (TIM)



Thermal Gap Filler (TGF)

Source: Ross Wilcoxon PhD, Engineering Fellow, Advanced Technology Center, Collins Aerospace Inc., Cedar Rapids IA USA. Unpublished; Used with permission.



TIMs for High Temperature Applications



Higher operating temperature can severely restrict available thermal solutions:

- May lead to increased focus on TIM *performance*, if the available thermal operating range is reduced;
- Requires selection of high-temperature-capable TIMs matched to specific expected application operating temperatures;
- Higher ambient temperature \implies higher device junction temperature;
- Ambient, junction, and processing temperature ranges will dictate parameters for suitable TIM selection.

Graphite Sheet Heat Spreaders



| Graphite Sheet Heat Spreader Materials | | | | | |
|--|--|-------------------|---------------------------|----------------|--|
| | | Thickness (μm) | Bulk Thermal Conductivity | | |
| Vendor | Product Designation | | X-Y axis W/mK | Z-axis W/mK | |
| DSN (China) | DSN5017 | 17 | 1600-1900 | 15-20 | |
| TTCL (China) | TGS-17 | 17 | 1700 | 15 | |
| Panasonic (Japan) | PGS EYG-S-25 | 25 | 1600 | N/A | |
| NeoGraf (US) | eGraf [®] SpreaderShield Flexible Graphite SS1500 | 17 | 1500 | 3.4 | |
| Panasonic (Japan) | PGS EYG-S-100 | 100 | 700 | N/A | |
| NeoGraf (US) | eGraf [®] SpreaderShield Flexible Graphite SS600 | 127 | 600 | 3.5 | |
| NeoGraf (US) | eGraf® HiTHERM™ 700 | 127 | 240 | 6 | |

Data Source: Vendor presentations and technical data sheets, DS&A LLC.

Carbon Nanotube Materials

Developments with vertically-aligned carbon nanotube TIMs (VA-CNTs):

- Advantages:
 - Perceived high bulk thermal conductivity of CNTs
- Disadvantages:
 - Significant difficulties in developing a manufacturable TIM product
 - Development materials in some cases have very low bulk thermal conductivity
 - High perceived manufacturing cost
- Fujitsu:
 - Tested values to date for bulk thermal conductivity (Z): 10-20W/mK

VA-CNT and VA-CNF TIMs are generally high temperature-capable (depending on carrier utilized).



Phase-Change Materials

Phase-change compounds have been manufactured for use as TIMs for more than thirty years and are wellknown for TIM2 applications:

- Compounds and pre-forms are available with phase-change temperatures from 45°C to 60°C:
 - Purpose of the phase-change temperature is to achieve thickness change to minimize resistance, at a given pressure (graph)
- Bulk thermal conductivity values are available in a wide range (depending on formulation): 0.6W/mK 8W/mK
- Certain new materials are available that utilize single-side and double-sided compound coatings on carriers:
 - Aluminum (dead soft)
 - Durable graphite films (certain manufacturers)
 - Dielectric films (i.e., DuPont[™] Kapton[®] MT, MT+)
- Application of a TIM pre-form with single-side coating in a test system to face the test head prevents marking or detritus on the DUT.
- Phase-change TIMs are high temperature limited (specifically depending on phase-change designed temperature and formulation characteristics).



Source, Graph: Berliner Nanotest und Design GmbH (Berlin, Germany). Well-known phase-change preform TIM (8μm initial thickness, prior to application of pressure).

US&A

High Performance Metallic TIMs: Indium Foils



Indium flat foils used as TIM2 for decades, for very specific applications:

- Flange-mount RF discrete power amplifiers and modules (telcom, radar, radio communications, satellite communications);
- Standard TIM2 for diode laser arrays¹;
- Reflowed indium solder as a high-volume TIM1 for server processors;
- TIMs and indium foils as seals for cryogenic systems;
- Semiconductor test and burn-in;
- Current research for high-volume BGA processor packages².

Notes: 1. Koechner, W., Solid-State Laser Engineering, 6th Edition (Springer Verlag, 2006).

2. Koh, Y. J.; Kim, S.H.; Sohn, E.S.; Khim, J.Y.; Amkor Technology Korea Inc., "Thermal Performance of Advanced TIMs for High-Power FCLBGAs," IEEE ECTC Conference 2022, San Diego CA USA, May 31, 2022.

High Performance Metallic TIMs: Patterned Metal Alloy Foils

Developments by Indium Corporation for indium and metal alloy foils as TIMs include:

- "Heat-Spring": Application of patterning to improve gap-filling and improve thermal performance for uneven surfaces;
- Laminated aluminum foil (5µ thickness, typ., one surface) available for:
 - Eliminating "tackiness" of indium metal on contact
 - Eliminate potential for residue in contact cycling for semiconductor test;
- Expansion of range of metal alloys available with above enhancements;
- Applications for gimbaled test heads and higher temperature testing.
- Taller patterns to handle greater die warpage and worse non-flat surfaces.
- Metallic TIMs may be temperature limited depending on alloy selected.

Note: "Heat-Spring" is a Registered Mark of Indium Corporation. US Patent 7,593,228-B2.

High Performance Metallic TIMs: Patterned Metal Alloy Foils

Comparative test data: indium flat foils vs. Indium "Heat-Spring" patterned In100 foil and thermal greases:

• Improvement: Patterning vs. flat indium foils, greases at > 40PSI (Note force reduction from points A to B)



Data Source: Indium Corporation. DS&A LLC Model 101 ASTM D5470-12 Test Stand. "Heat-Spring" is a registered mark of Indium Corporation. DS&A LLC - Thermal Interface Material Categorization and Selection

High Performance Metallic TIMs: Patterned Metal Alloy Foils

Bulk thermal conductivity and suggested maximum operating temperatures for metallic TIMs:

| Maximum Bulk Thermal Conductivity and Suggested Operating Temperature for Metallic TIMs | | | | | | |
|---|-------------------------------------|---|--|--|--|--|
| Metallic TIM Composition | Bulk Thermal Conductivity (W/mK) | Suggested Maximum Operating Temperature (°C) | | | | |
| 52In/48Sn Indalloy 1E | 34 | 100 | | | | |
| 80 In/20 Sn | 53 | 110 | | | | |
| 100 In | 86 | 125 | | | | |
| In/Al Clad | - | 125 | | | | |
| Sn, "Sn+" | 73 | 200 | | | | |
| 100 Pb | 35 | 250 | | | | |
| 100 Cu | 395 | 750 | | | | |

Table shows suggested values for selected metals and alloys; other alloys are possible.

• Characteristics of interface surfaces may affect maximum temperature.

Notes: * "Indalloy", "Sn+" are Indium Corporation products. Data Source: R. Jarrett, Indium Corporation, Utica NY USA; Bulk conductivity values, G. Wilson, Indium Corporation, Milton Keynes UK.

High Performance Metallic TIMs: New Developments



Examples: Relative bulk thermal conductivity values, development metallic TIMs of different types:

| Bulk Thermal Conductivity Values – Metallic TIMs | | | | | |
|--|---------------------|---------------------------------------|--------------------|--|--|
| Basis ¹ | Category | Type (Typical Intended Usage) | Value (W/mK, Typ.) | | |
| | Solid | Solder TIM (TIM1) | 70-86 | | |
| Indium Based | Soliu | Compressible TIMs (Patterned, TIM2) | 86 | | |
| | Phase-Change | Phase-change metal alloy TIMs (TIM2) | 40-50 | | |
| Indium (Callium ² | Unbrid Liquid Motol | Indium® m2TIM™ (TIM1) | 40-50 | | |
| Indium/Gailium ² | Hybrid Liquid Metai | Liquid metal pastes (TIM0, TIM1, TIM) | 15-25 | | |
| Gallium Based ² | Liquid | Liquid metal TIMs (TIM0, TIM1) | 20-45 | | |

Notes: 1. Primary metal by percentage. 2. Generalized statements regarding intended usages shown in parentheses. Multiple materials available from suppliers. Source: Adapted from: Miloš Lazić, Indium Corporation, "Advanced Gallium-Based Thermal Interface Materials," IMAPS New England Symposium 49, Boxborough MA USA, May 2, 2023. DS&A LLC - Thermal Interface Material Categorization and Selection

High Performance Metallic TIMs: Liquid Metal Developments

| Characteristics of Liquid Metal TIM Alloys | | | | | | |
|--|--------------------|------------------------------|------------------|--------------------------------|--|--|
| Composition | Melting Point (°C) | Density (g/cm ³) | Specific Gravity | Thermal Conductivity (W/mK) | | |
| 61.0Ga/25.0In/13.0Sn/1.0Zn | 7.6 | 6.50 | 6.50 | 15* | | |
| 66.5Ga/20.5In/13.0Sn** | 10.7 | 6.32 | 6.50 | 16.5 | | |
| 62.5Ga/21.5In/16.0Sn | 16.3 | 6.50 | 6.50 | 16.5 | | |
| 75.5Ga/24.5In | 15.7 | 6.35 | 6.35 | 26* | | |
| 95Ga/5In | 25.0 | 6.15 | 6.15 | 25* | | |
| Base Elemental Properties | | | | | | |
| 100Ga | 29.78 | 5.90 | 5.904 | 31 | | |
| 100Sn | 235 | 7.28 | 7.28 | 73 | | |
| 100In | 157 | 7.31 | 7.31 | 87 | | |

Notes: * Estimated value. ** Tradename "Gallinstan", Geratherm Medical AG. Sources: (1) Geratherm Medical AG, Material Safety Data Sheet, 93/112/EC, 2004. (2) Michael D. Dickey, et al., "Eutectic Gallium-Indium (EGaIn): A Liquid Metal Alloy for the Formation of Stable Structures in Microchannels at Room Temperature, "Advanced Functional Materials, 2008, 18, 1097-1104. (3) C.Y.Ho, et al., "Thermal Conductivity of the Elements," Journal of Physical Chemical Reference Data, Vol. 1. No. 2, 1972. (4) Charles Kittle, Introduction to Solid State Physics, 7th Ed., Wiley and Sons, 1996. Source: Adapted from: Jensen, T., Indium Corporation, "Innovative Metal TIM Technology for High Performance Computing." Semi-Therm 39 Symposium, San Jose CA USA, March 2023.

High Performance Metallic TIMs: Liquid Metal Developments **QDS&A** Applicability of liquid metal TIMs for semiconductor test:

- High relative thermal conductivity and excellent wetting characteristics;
- A very thin bond line can be achieved without reflow;
- Liquid metals must be contained, to prevent spread during application;
- Once applied, surface tension will typically hold material as desired;
- Varying metal constituencies will allow tailored melting points as required;
- Metals listed are not known to be toxic but care in handling is required;
- Liquid metals can be jetted to form dots on the intended surface;
- Significant global development interest for TIM0/TIM1 applications;
- Suitability for traditional semiconductor test applications has not been demonstrated, given contact/release and no-marking requirements.

Vertically-Aligned Carbon Fiber (VA-CNF) TIMs



| VA-CNF | | | | | |
|-------------------|---------------------------------------|-----------|---------------------------|----------------|--|
| Vendor | Product Designation | Thickness | Bulk Thermal Conductivity | | |
| | | (μm) | X-Y axis W/mK | Z-axis W/mK | |
| Dexerials (Japan) | EX20200XX Gap-filler | 100-200 | N/A | 15-20 | |
| NeoGraf (US) | Grafoil [®] GTA-005, GTA-030 | 130-760 | 140 | 5.5-7.0 | |
| Hitachi (Japan) | TC-001 | 150-500 | N/A | 40-90 | |

Data Source: Vendor presentations and technical data sheets, DS&A LLC.

Metal Alloy TIMs vs. VA-CNF and Graphite Films





Data Source: Indium Corporation. DS&A LLC Model 101 ASTM D5470-12 test stand.

Graphene-enhanced Graphitic Materials



New TIM developments include graphene-enhanced performance of graphite films:

• SHT "FrostSheet" is an example of such a newly-developed thermal material



Source: Murugesan, M.; Martinson, K.; Enmark, M.; Zhang, H.; Liu, J.; Almhem, L., "Applications of High Thermal Conductivity Graphene Enhanced Thermal Interface Materials," Smart High Tech AB, IMAPS France Thermal and Micropackaging Workshop 2023, Poitiers, France, March 8-9, 2023.

Graphene-enhanced Graphitic Materials



"Graphene-enhanced" performance of materials such as graphite films:

- SHT FrostSheet is an example of such a newly-developed thermal material;
- Such materials include developments for both TIMs and heat spreaders;
- SHT FrostSheet and GT-TIM GT-90SPRO data sheet values:
 - Bulk through-plane thermal conductivity: 90+/- 10 W/mK
 - Thickness: 300µm (0.012")
 - Fragile, relatively thin graphite materials
 - Subject to easy handling damage
 - No testing to date by DS&A to confirm test values.



Source: Murugesan, M.; Martinson, K.; Enmark, M.; Zhang, H.; Liu, J.; Almhem, L.; Smart High Tech AB, "Applications of High Thermal Conductivity Graphene Enhanced Thermal Interface Materials," IMAPS France Thermal and Micropackaging

Workshop 2023, Poitiers, France, March 8-9, 2023. Photograph: Smart High Tech AB (Göteborg, Sweden) "FrostSheet" enhanced graphite film: DS&A LLC (January 16, 2024).

DS&A LLC - Thermal Interface Material Categorization and Selection

Summary of New Material Developments



| High Performance Commercial TIM Materials - Examples | | | |
|--|-----------------------------|--|--------------------|
| TIM Classification | Vendor | Product | Status |
| Thermal Grease | Shin-Etsu/Japan | Gallium silicone grease | Commercial product |
| | Sumitomo/Japan | Nanoparticle Ni/Fe grease | (Indeterminate) |
| Metallic TIM | Enerdyne Corporation/USA | Liquid indium alloy on carrier | (Indeterminate) |
| | Indium Corporation/USA | Heat-Spring [®] patterned TIM | Commercial product |
| | Indium Corporation/USA | Indium alloy foil | Commercial product |
| | AIM/Canada | Indium alloy foil | Commercial product |
| | Kester/USA | Indium alloy foil | Commercial product |
Summary of New Material Developments



| High Performance Commercial TIM Materials - Examples | | | |
|--|---------------------------------------|---|--|
| TIM Classification | Vendor | Product | Status |
| | Btech Corporation/USA | Graphite fiber/polymeric carrier preform | Commercial product (Current status N/A) |
| Aligned Carbon Fiber/Polymeric | DuPont E&C/USA | Carbon fiber vertical array/polymeric carrier preform | Development |
| Matrix Carrier Preform | Honeywell Electronic Materials/USA | Graphite fiber/polymeric carrier preform | Commercial product (withdrawn) |
| | Hitachi/USA | Carbon fiber vertical array/polymeric carrier preform | Commercial product |
| | SHT AB/Sweden | Vertically-aligned CNT array in polymeric carrier | Development |
| CINT-Based | Carbice/Georgia Tech/USA | Infinity™ Vertically-aligned CNT- array in polymeric carrier | Commercial product |



B. Test Methodologies and Test Systems for Thermal Materials

TIM Test Methodologies: Overview



| Performance Property | Property Parameter | Method/Value |
|----------------------|---|---|
| Thermal Resistance | Through-plane (primary) bulk + contact = total thermal resistance | ASTM D 5470-17 (Steady-state, unidirectional controlled heat flow) JEDEC JESD 51-14 (In-situ, Transient with structure function calculations from electrical resistances) Thermal Test Vehicle (TTV, in-situ) |
| | Homogeneous, bulk (isotropic) | ASTM D5470-17 (Steady-state) JEDEC JESD 51-14 (Transient) Laser flash (Homogeneous materials) 3Ω Characterization |
| Thermal Conductivity | Non-homogeneous, bulk (through-plane) | ASTM D5470-17 (Steady-state, unidirectional flow) JEDEC JESD 51-14 (Transient) 3Ω Characterization |
| | Non-homogeneous, bulk (in- plane) | Nanotest LaTIMA (Steady-state, in-plane flow) Scanning pulsed laser |

Note: Not all test methods are suitable for testing certain categories of TIMs such as anisotropic and/or non-homogeneous structures (examples are compounds coated on a dielectric carrier or multilayer TIMs.)



DS&A LLC - Thermal Interface Material Categorization and Selection

TIM Evaluation: ASTM D 5470-17 Method

Standard TIM test stand: Berliner Nanotest TIMA5:

- Designed per ASTM D 5470-17, the industry-standard TIM test methodology for comparative material testing;
- System measures force applied, power (heat), thickness, thickness – with uniform heat flow.
- Measures thermal conductivity, calculated thermal resistance values w/error bars.
- Servo motor controls allow:
 - Extreme precision in measuring placement and thickness
 - Automation of functions (i.e., repeated contact/release cycle testing, to test for TIM durability for semi test.

Photograph: Berliner Nanotest und Design GmbH, Berlin, Germany. Nanotest TIMA5 ASTM D 5470-17 test stand.





TIM Evaluation: ASTM D 5470-17 Method



ASTM D 5470-17 describes a methodology to provide measurement of a thermal resistance value that is the sum of three constituent values:

• TIM thermal resistance *total* (θ_{TIM} or R_{th}) is the important value, in practice.



TIM Test Methodologies: ASTM D 5470-17 and Transient



ASTM D 5470-17 and transient methods are the primary test methods for determining bulk thermal conductivity and thermal resistance values.

- *TIM vendor data sheet values should be developed utilizing ASTM D 5470-17* for comparative values generated under:
 - Controlled surface conditions
 - Unidirectional heat flow conditions
 - Parallel contact surfaces
 - Precisely known clamping forces

ASTM D 5470 Purpose: Develop comparative test data under identical conditions with all extraneous factors (such as die warpage or non-co-planar contacting surfaces) removed.

- Use of JESD 51-14 transient methodology *follows after* ASTM D 5470 testing. Goal is to develop *in-situ* performance test values with a specific package surface, clamping mechanism, other variables.
- Transient methods use electrical characteristics of a DUT, such as a power semiconductor, in-situ.
- These two methods are complementary: *One does not replace the other*.

TIM Test Methodologies: ASTM D 5470-17 and Transient



| Method | Steady-State | Transient/Structure Function © 2022 - 2024 DS&A LLC |
|-------------------|--|---|
| Designation | ASTM D 5470-17 industry-wide standard | JEDEC JESD 51-14 semiconductor industry |
| Purpose | Highly-defined test data generated under specific controlled, known unidirectional flow conditionsPrimary industry standard for comparative performance | Data is generated under application-specific ("in-situ") conditionsStructure function knowledge required |
| Benefit | Enables independent test lab data comparisons across multiple labs, test stands Multiple types of tests, including mechanical reliability All types of TIM and thermal materials, including adhesives Multiple types of data generated: Thermal conductivity Thermal resistance vs. pressure range (0-140 PSI, typical) | Requires specific package type and die, to generate useful in-situ test data Characterizes internal package electrical and thermal performance Results can be imported to CFD models for that one specific package and one set of conditions. |
| Data Output Types | Known: Power, pressure, surfaces, heat flow Application-dependent variables removed Generate data sheet values under known conditions – vital for TIM manufacturers and for material-to-material performance comparisons Data is used for down selection to determine materials to test and evaluate. | Results will <i>not</i> necessarily correspond to ASTM D 5470-17 data – <i>by definition</i> Results will be tightly aligned to a specific package type, only |
| Ideal User | TIM and thermal material developers and manufacturers Industry OEM mechanical engineers Selecting TIMs for system design | Universities, semiconductor manufacturers |

TIM Evaluation: Thermal Test Vehicle (TTV)

Construction of a TTV:

- Standard 200mm wafer design with 4000 cells
- Diced to custom requirement
 - » $2.4 \times 2.4 \text{ mm}^2$ unit cells
 - » 8" wafer / > 4000 cells
 - » 500 µm undoped silicon
 - » Flip-chip assembly
 - \gg 50 \times 50 mm² maximum die size
 - Backside metallization:
 - » Option 1: NiV 300 nm | Pt 100 nm | Au 200 nm
 - » Option 2: Ti 100 nm | NiV 300 nm | Au 200 nm
 - » Option 3: Pure silicon
 - » Power density: Up to 10 W/mm²
 - » RTD Sensitivity 10 Ω/K







TIM Test Methods: Thermal Test Vehicles (TTV)



Thermal test vehicles are used for examining TIM performance in in-situ applications to measure:

- Performance of a TIM2 with a production semiconductor package;
- Performance of a TIM0 or TIM1 in contact with a die, to evaluate performance:
 - Given specific die warpage
 - With contact to lid (TIM1) or liquid cold plate/heat sink assembly (TIM0)
 - When well-designed, a tool that can provide very useful and detailed analytical capabilities for *in-situ* measurement for applications with a specified package type.



Sources: (Left) Berliner Nanotest und Design GmbH; (Right) Indium Corporation (with liquid cold plate applied to bare die TTV on engineering test board (ETB). (Photograph, DS&A LLC, January 16, 2024.)

Comparative Thermal Resistances: Reliability Testing



Impact of power cycling and bake testing on TIM types (following slides):

- Demonstrating the importance of comparative thermal resistance testing beyond time zero, for material evaluation
- ✓ Power cycling
 - Increasing thermal resistance values indicates decay in performance over time.
 - Declining thermal resistance values indicate TIM performance is *improving* over time.
- ✓ Bake cycling (90C)
 - Declining thermal resistance indicates bake-out of silicone oil carrier from thermal grease.

Patterned Metallic TIMs: Reliability





Note: Measured die surface temperature at time zero was shown to be approximately equivalent. Above test data taken after 3,000-hour bake test. Increased die surface temperature for Figure 4B reflects increased thermal resistance due to dry-out of silicone oil in the tested premium silicone-based thermal grease.

Data source: R. Jarrett, Indium Corporation, Utica NY USA. Die thermal test vehicles: Provided by Intel Corporation.

DS&A LLC - Thermal Interface Material Categorization and Selection

TIM Testing – Process Steps for Test Performance Methods



Example, aerospace systems manufacturer procedural sequence for TIM test methods:

| ASTM D-5470-17 Conduction Test Stand Baseline commercially available materials Preliminary characterization of Phase 1 "new technology investigation" (NTI) material | Characterize Phase 2 NTI material | Characterize Phase 3 NTI material |
|--|---|--|
| 2 Thermal Test Vehicle Design and validation of modular flip-chip TTV Preliminary testing with baseline (currently qualified for production) materials | Preliminary reliability testing (cycling, rework) w/baseline materials Preliminary comparative NTI material testing vs. baseline materials | Extended reliability testing (cycling, rework) w/ NTI materials |
| In-Situ Testing Requirements definition for in-situ test device Preliminary device identification, calibration | Design and validation of in-situ test device (RF PA) Preliminary testing with baseline materials | Design and validation of in-situ test device (digital component) Testing of NTI materials |
| Phase 1 | Phase 2 | Phase 3 |

Summary



TIMs are critical to efficient heat transfer from a semiconductor source.

- Understanding TIM types, testing methods is critical to proper evaluation.
- Specialized TIM types with very different requirements are required for challenging, highly-specialized applications in very different markets.
- Selection of a TIM is not based *only* on maximum bulk thermal conductivity.
- New development materials such as graphene-enhanced graphite, carbon fiber preforms, and certain new forms of liquid and hybrid liquid metallic TIMs are in development.
- Significantly higher temperatures, higher heat fluxes, greater die warpage, and cryogenic temperatures are challenging new requirements for TIMs.



Additional information on related topics:

Comparative thermal resistance – Dry junction

TIM Vendor Development Requirements TIM Development specifications for semiconductor test Phase Change-Coated Graphite Films and Reliability Testing Liquid immersion systems – Contamination sources Liquid immersion systems – Contamination and mitigation Liquid immersion systems – Challenges (Single- and two-phase) Quantum computing systems – TIMs suitable for cryogenic temperatures Cabot aerogel particles – Energy storage material developments

References

Comparative Thermal Resistances



Metal-to-metal surface contact resistance – comparison of two metals, three surface finishes (roughness), under load:



Source: M. Yovanovich, et al., "Calculating Interface Resistance", Electronics Cooling Magazine, May 1997, Vol. 3, No. 2. Note: Values are RMS values. 100 microinch = 2.54 microns.

Comparative Thermal Resistances



Comparison of surface roughness and relative interface thicknesses, to define a *general* application range for TIMs versus gap-fillers, under load:



These are rough estimates and values will vary with material properties and contact pressure (clamping force) applied.

Source: Ross Wilcoxon PhD, Senior Engineering Fellow, Advanced Technology Center, Collins Aerospace Inc., Cedar Rapids IA USA. Unpublished; Used with permission. Note: 100 microinches = 2.54 microns. Values are RMS values.

Comparative Thermal Resistances



Impact of a TIM versus dry contact on device operating temperature:

Three different TIM types tested versus dry contact



Source: K. Moody, R&D Manager, Kulicke & Soffa (USA). Note: All other conditions held equal.

TIM Test Methods: ASTM D 5470-17



ASTM D 5470-17 test methodology -- Example of comparative test data generated:

- Application of specified pressures significantly improves thermal resistance of many TIM types;
- Properly-designed test stand provides apples-to-apples comparative data, all factors equal.



Note: Specific TIM materials are not identified by vendor and vendor product identification. "Metal TIM" is indium metal flat foil.

Source: Ng Hooi Hooi, Thermal Test Solutions, Inc.; "Introduction to Thermal Interface Materials," BiTS Test Workshop, Mesa AZ USA, March 5-8. 2017.

Comparative Thermal Resistances: Reliability Testing





Source: Indium Corporation

Gap-Fillers: Cycling Reliability Testing



Mechanical cycling and other types of reliability testing over time can demonstrate useful results for evaluating TIMs.

- Previous reliability testing has been undertaken by Berliner Nanotest of "gap-filler" TIMs, examining cyclic compression and relaxation
- Gap-fillers may also be useful for test/burn-in with different reliability testing requirements.
 - An example is the use of so-called "gap-filler" TIMs for testing with PCBs and other substrates.
 - The same TIM test equipment described has also been used for reliability testing of metallic TIMs with contact/dwell/release cycling, to mimic semiconductor test requirements.



TIM Testing/Evaluation Methodologies



| TIM Testing – Environmental Conditions | | |
|--|----------------------------------|--|
| General Property Type | Failure Mode or Property | Methodology |
| Environmental | Outgassing, Weight Loss | Thermogravimetric analysis (TGA); ASTM E595 |
| | Humidity, Moisture | HAST 85/85 |
| Floctrical | Voltage Breakdown | ASTM D149 |
| | Flame Rating | UL-94 |
| | Thermal Resistance | ASTM D 5470-17 |
| | Thermal Conductivity | ASTM D 5470-17 |
| Thermal | Thermal Resistance (Alternative) | Transient Testing |
| | Thermal Resistance (Alternative) | Thermal Test Vehicle or TTC |

TIM Development – Test Equipment Manufacturers



| Selected TIM Test Equipment Manufacturers | | |
|---|--|------------|
| Company | Test Stand General Type | Status |
| | TIMA [®] ASTM D 5470-17 (Modified) | Production |
| Berliner Nanotest und Design GmbH | LaTIMA [®] In-Plane Bulk Thermal (X-Y) Conductivity Test Stand | Production |
| Berlin, Germany | Thermal Test Die, Thermal Test Wafers, Thermal Test Vehicles (TTVs) | Production |
| | Three-Omega Method Liquid/Gel Thermal Conductivity Test Stand | Production |
| Siemens (Mentor Graphic Mechanical Analysis Division) | "T3Ster" Structure Function Transient Test Stand; DynTIM™ Test Head | Custom |
| Zentrum für Wärmemanagement Stuttgart, Germany | Multiparameter Long-term Cyclic Load Test Stand Tensile and Compressive Load Test Stand | Custom |

TIM Vendor Development Requirements



| TIM Vendor Ty | vpical Devel | lopment Re | auirements |
|---------------|--------------|-------------|-------------|
| | | iopinent ne | yan cincinc |

| Thermal Impedance | Dielectric Strength** |
|---|---|
| Bond Line Thickness Post-Assembly | Cut-Through Resistance** |
| Thermal Conductivity | Thermal Cycling |
| Clamping Force Applied | Power Cycling |
| Wettability | Humidity and Bake |
| Thixotropicity | HAST |
| Dispensing/Placement Process Automation | Shock and Vibration |
| Cure Schedule* | Flammability |
| Adhesion, Peel Test* | Working Life |
| Contaminants | Storage/Transit Temperature Range (As Supplied) |
| Modulus of Elasticity | Shipment/Storage Temp Range (Complete Assembly) |
| Material Stability | Removability and Rework Process |
| Silicone Stability | Environmental and Recycling Process |
| Flammability | Cost |



| High Performance TIM Material Target Specifications for Test | | |
|--|--|--|
| Material Attribute | Goal ¹ | |
| Material Stability | No constituent run-out, no mechanical pump-out. Dimensionally stable; no moisture sensitivity during processing or normal operation in specified ambient environmental conditions. No fretting. | |
| Silicone Stability | No silicone content; no dry-out, no silicone oil separation; zero measurable separation by weight (TGA). | |
| Surface Wetting | TIM provides sufficient surface contact to approach 100% surface wetting in clamped condition, including expected warpage and specified surface conditions. | |

Notes: 1. Generalized statements, applicable to all levels of TIM (TIM0, TIM1, TIM2).



| High Performance TIM Material Target Specifications for Test | | |
|--|--|--|
| Material Attribute | Goal ¹ | |
| Thermal Performance | Target and stretch goals for thermal resistance to meet system maximum heat load and heat flux. | |
| Outgassing | No permissible outgassing per NASA, aerospace applications requirements; no outgassing for medical, optical, optoelectronic applications and systems | |
| Environment | Suitable for shipment, storage, processing, operational temperatures (ambient, junction/module) | |
| Cost | Budget goals met with volume manufactured TIM. | |

Notes: 1. Generalized statements, applicable to all levels of TIM (TIM0, TIM1, TIM2).



| High Performance TIM Material Target Specifications for Test | | |
|--|--|--|
| Material Attribute | Goal ¹ | |
| Conformability | Same TIM conforms to different die sizes, lid sizes without damage or change in performance. ² TIM conforms to 90 bending and wrapping around test head/socket lid configuration. ² | |
| Particulates | No permissible loss of particulates, fibers. ² No residue visible, remaining on DUT after contact; no detritus. ² | |
| Durability | Tested cycling survival through X number of repeated contact-and-release cycles. ² | |

Notes: 1. Previous statements are applicable to all levels of TIM (TIM0, TIM1, TIM2).

2. Statements specific to semiconductor test and liquid immersion systems.



| High Performance TIM Material Target Specification for Test | | |
|---|---|--|
| Product Attribute | Goal* | |
| Thermal Resistance | Target: < 0.35°C-cm²/W @ Minimum clamping force applied Stretch: < 0.15°C-cm²/W @ 60PSI clamping force applied | |
| Contact, Non-Coplanar Surfaces | Target: 1,000 – 5,000 Cycles Stretch: 5,000 – 15,000 | |
| Thermal Conductivity | 30W/m-K ■ (Minimum) >100W/m-K ▲ (Ideal) | |
| Operating Temperature | -15°C to 120°C ■ (Minimum) -40°C to 200°C ▲ (Ideal) | |

Key to symbols: A Market leading product. Market improvement w/equivalent or better pricing. * Generalized statements. Source: DS&A LLC.



| Examples of TIM2 Developments | | | | | |
|--|-----------------------|---------------------------------|-----------|-----------|-----------------------------------|
| Thermal Material General Type | Thermal Resistance | Temperature Range Capability | Suppliers | Cost | Development Status |
| VA-CNT* | Very Low | Wide | Limited | Very High | Development, Early Prototyping |
| VA-CNF** | Very Low | Wide | Limited | Moderate | Development, Early Prototyping |
| Graphite Heat Spreaders | High | Very Wide+ | Many | Moderate | Production |
| Al Foils+Compound (Non-Silicone) | Low | Wide | Limited | Low | Production |
| Patterned Metallic Foils | Very Low | Wide | Limited | Moderate | Production |

Notes: VA-CNT: Vertically-aligned carbon nanotube array in carrier. VA-CNF: Vertically-aligned carbon fiber or graphite particulates in carrier.

+ Graphite heat spreaders are highly anisotropic and are not TIMs; temperature tolerance to 400+ $^\circ$ C.

Source: DS&A LLC.

TIM commercial products developed for semiconductor test requirements, included in Phase I test program:

| Thermal Interface Materials Tested | | | | |
|------------------------------------|--|--|--|--|
| Graph Key | Description | | | |
| CLAD | Indium (99.99%) flat foil, one side only 5μ aluminum cladding | | | |
| CLAD HSK | Indium (99.99% foil, one side only 5 μ aluminum cladding, HSK pattern applied* | | | |
| Al Foil, One-side coated | Aluminum foil 50 μ thickness, coated one side with dry thermal compound** | | | |

Note: * Indium Corporation Heat-Spring® HSK. ** Development material only.



Current development of phase-change coated graphite film carriers by Streuter Technologies:

- Data sheet test values per ASTM D 5470.
- Decades of proven compound coating experience processes for TIM materials, to date;

Streuter Technologies is now offering different versions of this product type:

- Single-side phase-change coating on film graphite film for semiconductor test applications;
- Single- and double-sided coatings in different thicknesses, as required;
- Multiple combinations of options in performance and durability testing:
 - Carrier (20-, 32-, 40-, 70-micron thicknesses)
 - Coating thickness and custom footprint/offset compound coatings
 - Phase-change temperature (52°C, 60°C)
- High degree of surface wetting achieved addressing surface warpage and roughness.
- Certain graphite films are highly durable and have passed significant 90-degree bend testing over tens of thousands of bend cycles appropriate for semiconductor test.

Source: Streuter Technologies, Inc. (www.stretech.com)



32micron graphite film: 71% Improvement at low pressure (5 PSI), single-side coating vs. uncoated

40micron graphite film: 70% Improvement at medium (40 PSI) pressure, double-side coating vs. uncoated



2





Source: Berliner Nanotest und Design GmbH.





Source: Berliner Nanotest und Design GmbH. Observed variation (>800 cycles) for indium flat foil with al-cladding caused by an error with cold plate water supply. Testing concluded at 1,000 cycles (with exception of patterned In HSK +5µ Al cladding).



Challenges for Immersion Liquid Cooling Systems
Liquid Immersion Systems: Contamination Sources



Immersion Liquid Cooling Systems – Potential Contamination Sources

| Material Source of Contaminant | Rectifier | Server | Cabling | Tank | Example of Component Containing Contaminant | Mitigation/Comment | | |
|-----------------------------------|-----------|--------|---------|------|---|-------------------------|--|--|
| PVC insulation | • | • | • | | Wiring: Communication and power cables, etc. | Use cleaner alternative | | |
| Silicone RTV | • | | | | Transistor potting, vibration dampening capacitors | | | |
| Elastomers | | | | • | ank o-rings, seals, etc. Minimize; use cleanest optior | | | |
| Hot-melt adhesives | • | | | | Nire retention | | | |
| Electrical Isolation Pads | • | | | | ower supply transistors and diodes * | | | |
| Heat-Shrink Tubing | • | | | | Niring, cable assemblies Minimize use | | | |
| TIM - Thermal grease | • | • | | | Transistor and diode heat sinks * | | | |
| TIM - Thermal grease | | • | | | Heat sink attach to processors OK to use but alternatives exi | | | |
| TIM – Gap-fillers | • | • | | | Attach heat sinks for voltage regulators, diodes, etc. * | | | |

Note: * Eliminated in two-phase operation. Source: Panel Discussion, "One Year of Two Phase (2P) Immersion Cooling in the Cloud: Lessons Learned", Raniwala, A. (moderator); Alissa, H., Manousakis, I., Shaw, M., Microsoft Corporation; Tuma, P., 3M Company; Chen, S., Wiwynn. OCP Global Summit, November 9-10, 2021.

Liquid Immersion Systems: Contamination Sources



Immersion Liquid Cooling Systems – Potential Contamination Sources

| IC or Power Component Type | Processor | AI/GPU | ASIC | RDIMM | VRM | Power Device | Material | Challenge | | | |
|-------------------------------|-----------|--------|------|-------|-----|--------------|------------------------------------|---|--|--|--|
| TIM1 | • | • | • | | | | Polymeric TIM, gel, thermal grease | | | | |
| TIM1 | • | • | • | | | | Hybrid/liquid metallic TIM | | | | |
| тімо | • | • | • | • | | | Polymeric TIM, thermal grease | Potential for cavitation, extraction, or | | | |
| TIM2 | • | • | • | • | • | | Polymeric TIM, gel, thermal grease | substances (such as silicone oil carrier) | | | |
| Gap-fillers | | | | • | • | • | Silicone/siloxanes and polymeric | | | | |
| Lid seal adhesives | • | • | • | | | | Epoxy, one-part silicones, other | | | | |

Liquid immersion (1P/2P) requires evaluation of many materials within a server:

- Potential for extraction of constituents from each material type by the fluid;
- *Potential for fouling of the immersion fluid* by extracted hydrocarbons, constituents, other particulates;

• Potential for fouling of filters and other system components with extracted and redeposited constituents. Note: * Eliminated in two-phase operation. Source: Panel Discussion, "One Year of Two Phase (2P) Immersion Cooling in the Cloud: Lessons Learned", Raniwala, A. (moderator); Alissa, H., Manousakis, I., Shaw, M., Microsoft Corporation; Tuma, P., 3M Company; Chen, S., Wiwynn. OCP Global Summit, November 9-10, 2021.

Liquid Immersion Systems: Contamination Sources



Example -- Simple immersion fluid contamination test with four different types of TIM2:

Fluid: PAO6 with 30-second agitation after insertion of TIM:

- Polymeric phase-change compound
- Silicone oil carrier thermal grease
- Indium metal foil



Source: Test and photograph - A. Mackie, Indium Corporation, February 2023. Used with permission. Similar testing undertaken at 3M Company, Specialty Liquids.

Liquid Immersion Systems: Contamination, Mitigation



| TIMs for Liquid Immersion | | | | | | |
|--|--------------------------------|---|--|--|--|--|
| TIM Type | Potential for Contamination | Mitigation/Comment | | | | |
| Silicone Thermal Grease (<4% silicone) | Minimal | Currently in use | | | | |
| Silicone Thermal Grease (4-16% silicone) | Significant | Select better formulation w/reduced silicone oil content | | | | |
| Gap-fillers | Significant | Concern for silicone content. Eliminated in 2/P operation. | | | | |
| Graphite film/sheet | None | Concern for potential fretting, electrically conductive (not yet tested) Evaluation needed: Potential for air entrapment in interface ² (Heat spreaders w/poor through-plane effective conductivity) | | | | |
| Indium foil Patterned indium foils ² | None | Currently in use | | | | |
| Hybrid/liquid metals; solid/liquid hybrids | Unknown | Evaluation needed | | | | |
| Soldered joint | None | Residual flux will redeposit on contacts for power components, causing shorting (Two-phase systems) | | | | |
| Sintered foil/sintered joint | None | No compatibility testing identified to date* | | | | |

Joining materials, not TIMs. Included for completeness.

Notes: 1. Indium Corporation Heat-Spring[®] and similar.

2. See investigation: Coles, H., Herrlin, M., "Immersion Cooling of Electronics in DoD Installations," DOD ESTCP Project EW-201347, Lawrence Berkeley National Laboratory Report (May 2016).

* Suggested for academic investigation.

DS&A LLC - Thermal Interface Material Categorization and Selection

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Liquid Immersion: TIM Challenges (Single-, Two-Phase)

Pre-attachment of TIM2 to heat sink or boiling enhancement plate:

- Important for both single- and two-phase expanded heat transfer components
- Pre-attachment process methods for indium foil and patterned indium foils:
 - A: Pressure attachment, Indium Heat-Spring[®] patterned foils (see illustration of TIM2 applied without adhesive);
 - B: Indium Corporation NC-702 tacking agent (pending liquid immersion fluid testing for potential for fluid contamination).



Source: Source: T. Jensen, Indium Corporation, USA. Photograph: DS&A LLC. IBM Power 9 Monza heat pipe/heat sink assembly with Indium Heat-Spring[®] pre-attached TIM2 by heat sink vendor.

Quantum Computing Systems: Suitable TIMs for Cryogenics



Cryogenic cooling systems for quantum computing: Other metals and materials as potential TIMs

Reference (Bradley, Radebaugh) details the following properties for a number of materials operating at cryogenic temperatures (generally, 4K to 300K), as calculated values based on the original works:

- Thermal conductivity
- Specific heat
- Linear thermal expansion
- CTE
- Young's modulus

This materials data is consolidated from a large testing database created by the (US) National Institute of Standards and Technology (NIST) in the 1970 time period and published in multiple out-of-print agency reports. The purpose of the reference document was to consolidate and make available all of this data in a single on-line reference source.

- Materials included are commonly used in cryogenic system assembly.
- A very limited number of TIMs are suitable for use at cryogenic temperatures: See table following.

Source: Bradley, P., Radebaugh, R., "Properties of selected Materials at cryogenic temperatures," CRC Press, Boca Raton FL, 2013. Web: https://tsapps.nist.gov/publication/get_pdf.cfm?pub_id=913059

Quantum Computing Systems: Suitable TIMs for Cryogenics



| Thermal Interface Materials for Cryogenic Temperatures | | | | | | |
|--|-------------------------|-----------------------------|--------------------|--|--|--|
| Material | Vendor(s) | General Type | Format | | | |
| Apiezon [®] -N | M&I Materials Ltd. (UK) | Thermal Grease | Dispensed compound | | | |
| Indium foil (In 99.99%) | Many | Metal foil | Pre-form, die-cut | | | |
| Indium wire (In 99.99%) | Many | Metal wire | Drawn wire | | | |
| Heat-Spring [®] (In 99.99%) | Indium Corporation (US) | Metal foil, patterned | Pre-form, die-cut | | | |
| Tin | Many | Metal foil | Pre-form, die-cut | | | |
| Indium-copper | Many | Metal foil laminate or clad | Pre-form, die-cut | | | |

Source: Dillon, A.; McCusker, K.; Van Dyke, J.; Isler, B.; Christiansen, M.; "Thermal interface material characterization for cryogenic electronic packaging solutions," IOP Conference Series: Materials Science and Engineering 278 (2017) 012054. doi: 10.1088/1757-899X/278/1/012054.

Notes: Apiezon[®] is a registered trademark of M & I Materials Ltd., UK. Heat-Spring[®] is a registered mark of Indium Corporation (US).

Aerogel Particles – Energy Storage Materials Development

Cabot aerogel particles for *thermal barrier* developments for energy storage:

| | Pouch & Prisn | natic Cell Type | Key Performance Factors | | | | | |
|----------------------------|---------------|-----------------|-------------------------|----------|------------|-------------------------|---------|--|
| Material | Cell-to-cell | Pack level | Thermal insulation | Thinness | Max. temp. | Electrical isolation | Density | |
| Aerogel | 0 | 0 | | • | • | \bullet | | |
| Ceramic paper | | • | 0 | 0 | | | | |
| Mica sheet | • | 0 | 0 | | | | 0 | |
| Coatings | | 0 | 0 | | 0 | | 0 | |
| Encapsulating foams | • | • | • | N/A | • | • | ٠ | |
| Compression pads (foam) | • | ۲ | • | • | 0 | \bigcirc | • | |

Source: IDTechEx, adapted by Cabot Corporation

Source: Cabot Entera^M Aerogel: Mitigating Thermal Runaway Risk in Battery Electric Vehicles (webinar). https://www.cabotcorp.com/solutions/products-plus/aerogel/particles-for-ev-thermal-barriers

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Aerogel Particles – Energy Storage Materials Development

Cabot aerogel particles for *thermal barrier* developments for energy storage:

| | PRODUCT FEATURES | | |
|-------------------------------|-------------------------|--------------------------|--|
| PROPERTY | ENTERA EV5200 | ENTERA EV5400 | |
| Particle size range | 0.1-1.2 mm | 0.1-0.5 mm | |
| Pore diameter | ~20 nm | ~20 nm | |
| Bulk density | 75-95 kg/m ³ | 75-100 kg/m ³ | |
| Particle thermal conductivity | 12 mW/m-K | 12 mW/m-K | |
| CAS RN | 102262-30-6 | 102262-30-6 | |
| Surface chemistry | Hydrophobic | Hydrophobic | |

Source: Cabot Entera™ EV5400 aerogel data sheet. https://www.cabotcorp.com/solutions/products-plus/aerogel/particles-for-ev-thermal-barriers

Aerogel Particles – Energy Storage Materials Development

Cabot aerogel particles for *thermal barrier* developments for energy storage:



Note: Thermal resistivity is the thickness needed to achieve a certain level of insulation (measured by dividing thickness by thermal conductivity).

Source: Cabot Entera^M Aerogel: Mitigating Thermal Runaway Risk in Battery Electric Vehicles (webinar). https://www.cabotcorp.com/solutions/products-plus/aerogel/particles-for-ev-thermal-barriers

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